Docket No.

UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION Hiroyuki YANO, et al.

SERIAL NO:

09/531,163

FILED: FOR:

March 17, 2000

GAU:

1756

EXAMINER:

D. DEO

AQUEOUS DISPERSION, AQUEOUS DISPERSION FOR CHEMICAL MECHANICAL POLISHING USED FO MANUFACTURE OF SEMICONDUCTOR DEVICES, METHOD FOR MANUFACTURE OF SEMICONDUC

DEVICES, AND METHOD FOR FORMATION OF EMBEDDED WIRING

INFORMATION DISCLOSURE/RELATED CASE STATEMENT UNDER 37 C

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

SIR:

OCT 1 1 2001

Applicant(s) wish to disclose the following information.

TC 1700

REFERENCES

- The applicant(s) wish to make of record the references listed on the attached form PTO-1449. Copies of the listed references are attached, where required, as are either statements of relevancy or any readily available English translations of pertinent portions of any non-English language references.
- A check is attached in the amount required under 37 CFR §1.17(p).

RELATED CASES

- Attached is a list of applicant's pending application(s) or issued patent(s) which may be related to the present application. A copy of the patent(s), together with a copy of the claims and drawings of the pending application(s) is attached along with PTO 1449.
- ☐ A check is attached in the amount required under 37 CFR §1.17(p).

CERTIFICATION

- ☐ Each item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

DEPOSIT ACCOUNT

Please charge any additional fees for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to deposit account number 15-0030. A duplicate copy of this sheet is enclosed.

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Respectfully submitted,

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Re: In re Application of: Hiroyuki YANO, et al.

U.S. Application Serial No.: 09/531,163

Filing Date: March 17, 2000

For: AQUEOUS DISPERSION, AQUEOUS DISPERSION FOR CHEMICAL

MECHANICAL POLISHING USED FOR MANUFACTURE OF SEMICONDUCTOR DEVICES, METHOD FOR MANUFACTURE OF SEMICONDUCTOR DEVICES, AND METHOD FOR FORMATION OF

EMBEDDED WIRING Group Art Unit: 1765 Examiner: D. DEO

STATEMENT OF RELEVANCY

The references cited on the attached Form PTO-1449:

The two catalogues describe the IC1000 pad.